Special Issue

Digitally Manufactured Microfluidics and Microsystems

Message from the Guest Editors

Digital manufacturing (DM) is a family of computercentered processes that integrate digital 3D designs, automated (additive or subtractive) fabrication, and device testing in order to increase fabrication efficiency. Importantly, DM enables the inexpensive realization of 3D designs that are impossible or very difficult to mold. This Special Issue showcases research papers, communications, and review papers that highlight the latest developments in the DM of microfluidics and microsystems, including additive or subtractive manufacturing processes such as stereolithograpy (SLA), digital light processing (DLP)-based SLA, twophoton direct laser writing (DLW), Continuous Liquid Interface Printing (CLIP), PolyJet, fused deposition modeling (FDM), direct sound printing (DSP), volumetric printing, laser cutting, CNC milling, 3D-printed molds, and bioprinting, particularly advances in resins and resolution and the biological, biochemical, biophysical, and biomedical applications of additive manufacturing. This Issue will be published as an open-source book of wide dissemination and impact.

Guest Editors

Prof. Dr. Albert Folch

Prof. Dr. Savas Tasoglu

Dr. Mohsen Habibi

Prof. Dr. Muthukumaran Packirisamy

Deadline for manuscript submissions

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Micromachines
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
micromachines@mdpi.com

mdpi.com/journal/micromachines





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About the Journal

Message from the Editor-in-Chief

You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

Editor-in-Chief

Prof. Dr. Ai-Qun Liu

- 1. Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China
- 2. School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore 639798, Singapore

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